



Docket No. 740819

9/5/03  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Yoshiyuki TANI

Serial No. 09/874,367

Filed: June 6, 2001

For: PHOTOMASK MAKING METHOD  
AND ALIGNMENT METHOD

)

) Group Art Unit: 1756

) Examiner: Christopher G. Young

) Confirmation No. 2951

) Date: August 29, 2003

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CERTIFICATE OF MAILING OR TRANSMISSION  
[37 CFR 1.8(a)]

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Signature: \_\_\_\_\_

Name: \_\_\_\_\_

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed April 1, 2003, please consider the following amendments and remarks in connection with the above-identified application.

09/08/2003 CSIAS1 00000002 192380 09874367

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